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LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					APPLICANT David L. Dickerson et al.			
					FILING DATE March 11, 2004		GROUP 2814	
U.S. PATENT DOCUMENTS								
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	AL							
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OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
A.M	AR	K. Ohe et al., "Narrow-Width Effects of Shallow Trench-Isolated CMOS with n+ Polysilicon Gate," IEEE Vol. 36, © 1989, pgs. 1110-1118.						
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